

Application Number: Unknown
 Filing Date: Unknown
 First Named Inventor: Richard A. Blanchard
 Group Art Unit: Unknown
 Examiner Name: Unknown
 Attorney Docket: BLAN-9

FORM PTO-1449
COMMERCE

U.S. DEPARTMENT OF
PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

37 CFR 1.98(b)

U.S. Patent Documents						
Examiner Initials	Cite No.	U.S. Patent Number	Kind Code	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YY	Pages, Columns, Lines Where Relevant Passages or Figures Appear
<i>cl</i>		6,331,470		Sanfilippo et al.	12-18-01	<u> </u>
		6,277,703		Barlocchi et al.	8-21-01	<u> </u>
		6,204,098		Anceau	3-20-01	<u> </u>
		6,166,436		Maeda et al.	12-26-00	<u> </u>
		6,060,381		Nakagawara et al.	5-9-00	<u> </u>
		6,020,215		Yagi et al.	2-1-00	<u> </u>
		5,891,797		Farrar	4-6-99	<u> </u>
		4,920,639		Yee	5-1-90	<u> </u>
		4,824,795		Blanchard	4-25-89	<u> </u>
<i>cl</i>		4,592,802		Deleonibus et al.	6-3-86	<u> </u>

Foreign Patent Documents								
Examiner Initials	Cite No.	Office	Number	Kind Code	Name of Patentee or Applicant	Date of Publication MM-DD-YY	Location of Relevant Passages/Figures	T

Other Prior Art - Non Patent Literature Documents								
Examiner Initials	Cite No	Name of Author (All Caps), Title of Article/Item, Date, Page(s), Volume-Issue Number(s), Publisher, City and/or Country Where Published						T
<i>cl</i>		KELLY, ET AL., Galvanic Cell Formation: A Review of Approaches to Silicon Etching for Sensor Fabrication, August 2001, IEEE Sensors Journal, Vol 1, No. 2, pg. 127-142.						
<i>cl</i>		LEE, The Fabrication of Thin, Freestanding, Single-Crystal, Semiconductor Membranes, August 1990, J. Electrochem. Soc., Vol. 137, No. 8, pg. 2556-2574.						

Examiner Signature	Date Considered
<i>calvache</i>	5-20-04

**EXAMINER: Initial citation considered. Draw line through citation if no in conformance and not considered. Include copy of this form with next communication to application.